⇒ PN-12α·PN-50α PN type checker; Contact type(PN-12α) & Non-contact type(PN-50α)



Selling Points

Principle: Themo-electromotive force(seebek effect) Possible to check most figure of sample such as single crystalline silicon wafer, bulk, ingot and so on *Please select from 2 types:

- 1) 2 probe ver. (Hot probe, Cold probe),
- 2) 1 probe ver.(Hot & Cold probe)

Details

Sample sizes

more than 2 inch

Measuring range

PN Checking range in resistivity: 1m ~ 20k Ω·cm *Polycrystalline silicon, thin film on wafer, MultiOxidized film on wafer surface are can not judgement







Selling Points

Principle: Photovoltaic effect by light pulse irradiation No damage and no stain by Non-contact method Possible to check even oxidized film on wafer surface Instantly discrimination by optical pulse illuminate

Details

Sample sizes

more than 30x30mm

Measuring range

PN Checking range in resistivity: 0.1~1.000Ω·cm

